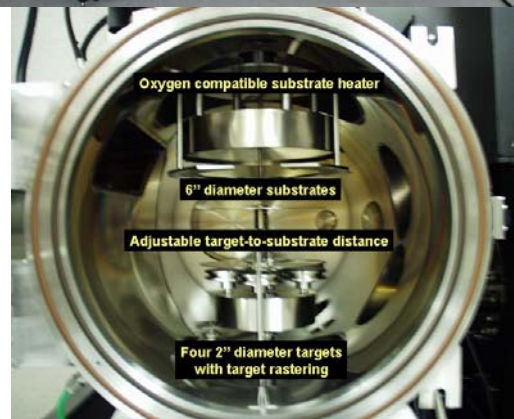
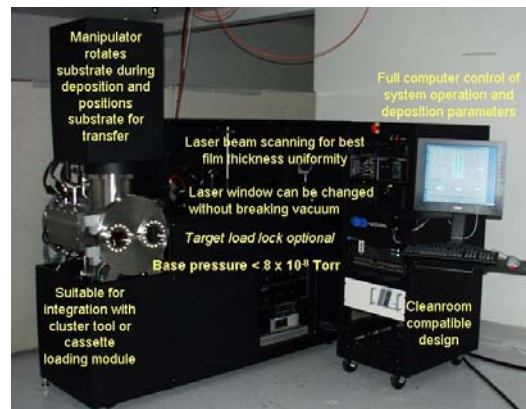
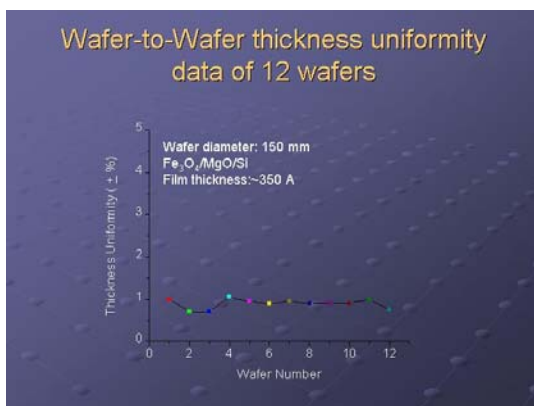
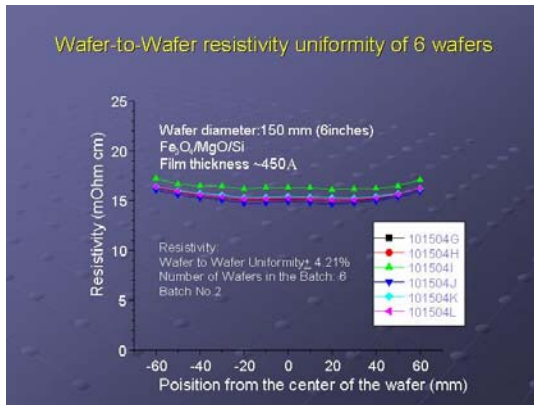
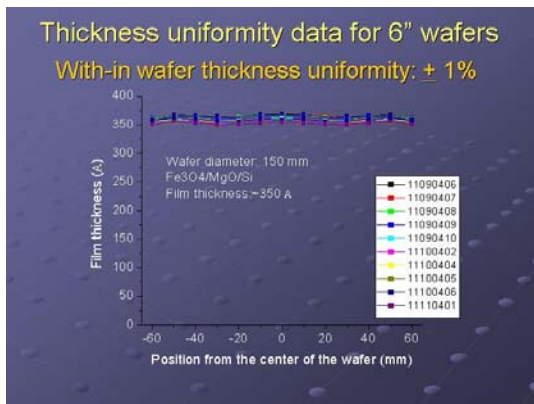


## Pulsed Laser Deposition Cluster Module



Neocera announces its first commercial Pulsed Laser Deposition (PLD) cluster module designed and developed for continuous wafer processing of 150 mm wafers (6-inch diameter). This module has been successfully integrated in a cluster tool environment, and is producing high quality thin films.

Cluster tools are multi-chamber, modular, integrated process technology platforms and form critical components in continuous wafer processing required in high volume manufacturing. A high-degree of equipment reliability, process reproducibility and smooth integration are some of the stringent requirements for cluster modules.



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